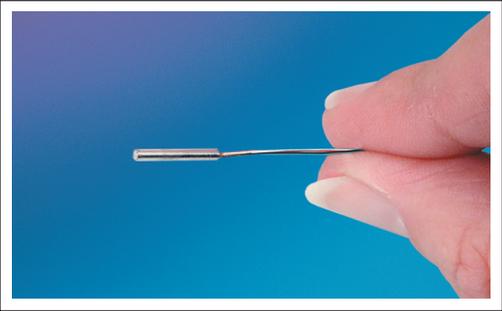


Kulite
ULTRAMINIATURE
PRESSURE TRANSDUCER

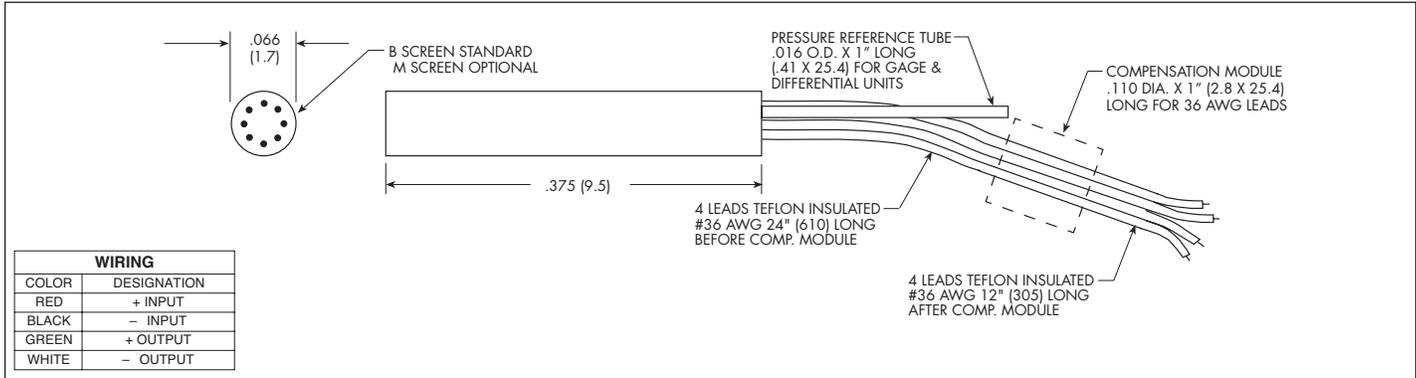
XCQ-062 SERIES

- Ideal For Turbine Engine Probes and Wind Tunnel Applications
- 50 Year History Of Successful Applications In Wind Tunnel And Flight Test Programs
- Patented Silicon on Silicon Integrated Sensor **VIS**[®]
- Size And Shape Ideal For Incorporation In User Designed Probes
- Excellent Static And Dynamic Performance



The XCQ-062 Series allows for a very rugged package suited for probes, pressure rakes and other similar test set ups. This transducer is well suited for both dynamic and static pressure measurements in benign or harsh environments.

Kulite recommends the **KSC Series** of signal conditioners to maximize the measurement capability of the XCQ-062 transducer.



INPUT	Pressure Range	.35 5	0.7 10	1 15	1.7 25	3.5 50	7 100	17 250	35 500	70 BAR 1000 PSI	
	Operational Mode	Absolute, Gage, Differential			Absolute, Gage, Sealed Gage, Differential			Absolute, Sealed Gage			
	Over Pressure	2 Times Rated Pressure									
	Burst Pressure	3 Times Rated Pressure									
	Pressure Media	All Nonconductive, Noncorrosive Liquids or Gases									
	Rated Electrical Excitation	10 VDC/AC									
	Maximum Electrical Excitation	12 VDC/AC									
	Input Impedance	1000 Ohms (Min.)									
OUTPUT	Output Impedance	1000 Ohms (Nom.)									
	Full Scale Output (FSO)	100 mV (Nom.)									
	Residual Unbalance	± 5 mV (Typ.)									
	Combined Non-Linearity, Hysteresis and Repeatability	± 0.1% FSO BFSL (Typ.), ± 0.5% FSO (Max.)									
	Resolution	Infinitesimal									
	Natural Frequency of Sensor Without Screen (KHz) (Typ.)	150	175	200	240	300	380	550	700	1000	
	Acceleration Sensitivity % FS/g Perpendicular	1.5x10 ⁻³	1.0x10 ⁻³	6.5x10 ⁻⁴	5.0x10 ⁻⁴	3.0x10 ⁻⁴	1.5x10 ⁻⁴	1.0x10 ⁻⁴	6.0x10 ⁻⁵	4.5x10 ⁻⁵	
	Insulation Resistance	100 Megohm Min. @ 50 VDC									
ENVIRONMENTAL	Operating Temperature Range	-65°F to +250°F (-55°C to +120°C)									
	Compensated Temperature Range	80°F to +180°F (25°C to +80°C) Any 100°F Range Within The Operating Range on Request									
	Thermal Zero Shift	± 2% FS/100°F (Typ.) (± 3% FS/100°F Max.)					± 1% FS/100°F (Typ.) (± 2% FS/100°F Max.)				
	Thermal Sensitivity Shift	± 2% /100°F (Typ.) (± 3% /100°F Max.)					± 1% /100°F (Typ.) (± 2% /100°F Max.)				
	Steady Acceleration	10,000g. (Max.)									
PHYSICAL	Linear Vibration	10-2,000 Hz Sine, 100g. (Max.)									
	Electrical Connection	4 Leads 36 AWG 36" Long									
	Weight	.2 Gram (Nom.) Excluding Module and Leads									
Pressure Sensing Principle	Fully Active Four Arm Wheatstone Bridge Dielectrically Isolated Silicon on Silicon										

Note: Custom pressure ranges, accuracies and mechanical configurations available. Dimensions are in inches. Dimensions in parenthesis are in millimeters. All dimensions nominal. (U) Continuous development and refinement of our products may result in specification changes without notice. Copyright © 2014 Kulite Semiconductor Products, Inc. All Rights Reserved. Kulite miniature pressure transducers are intended for use in test and research and development programs and are not necessarily designed to be used in production applications. For products designed to be used in production programs, please consult the factory.



MINIATURE PRESSURE TRANSDUCER

XCQ-080 SERIES

- Ideal For Turbine Engine Probes and Wind Tunnel Applications
- 50 Year History Of Successful Applications In Wind Tunnel And Flight Test Programs
- Patented Silicon on Silicon Integrated Sensor **VIS**[®]
- Size And Shape Ideal For Incorporation In User Designed Probes

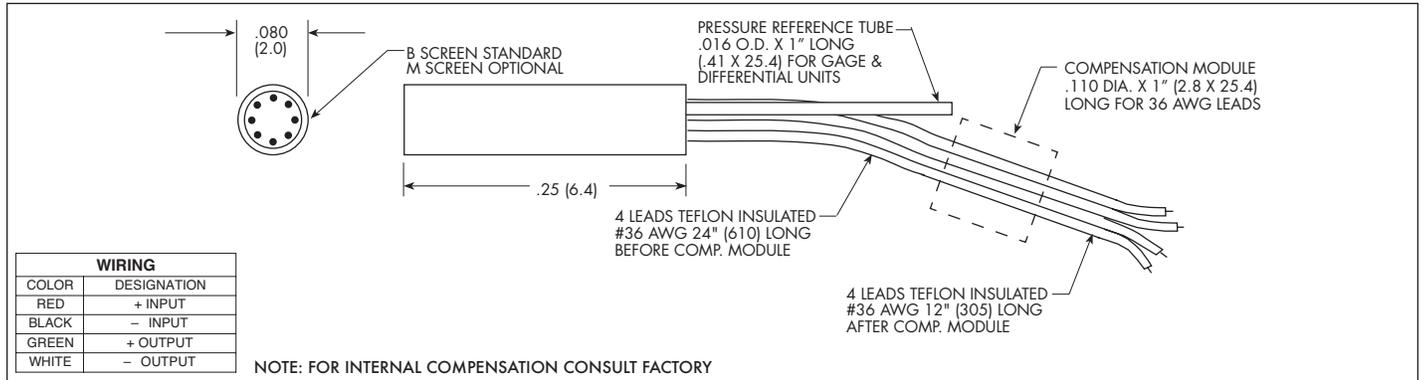
Probes

- Excellent Static And Dynamic Performance

The XCQ-080 Series allows for a very rugged package suited for probes, pressure rakes and other similar test set ups. This transducer is well suited for both dynamic and static pressure measurements in benign or harsh environments.



Kulite recommends the **KSC Series** of signal conditioners to maximize the measurement capability of the XCQ-080 transducer.



INPUT	Pressure Range	0.35 5	0.7 10	1 15	1.7 25	3.5 50	7 100	17 250	35 500	70 BAR 1000 PSI	
	Operational Mode	Absolute, Gage, Differential			Absolute, Gage, Sealed Gage, Differential			Absolute, Sealed Gage			
	Over Pressure	2 Times Rated Pressure									
	Burst Pressure	3 Times Rated Pressure									
	Pressure Media	All Nonconductive, Noncorrosive Liquids or Gases									
	Rated Electrical Excitation	10 VDC/AC									
	Maximum Electrical Excitation	12 VDC/AC									
	Input Impedance	1000 Ohms (Min.)									
OUTPUT	Output Impedance	1000 Ohms (Nom.)									
	Full Scale Output (FSO)	100 mV (Nom.)									
	Residual Unbalance	± 5 mV (Typ.)									
	Combined Non-Linearity, Hysteresis and Repeatability	± 0.1% FSO BFSL (Typ.), ± 0.5% FSO (Max.)									
	Resolution	Infinitesimal									
	Natural Frequency of Sensor Without Screen (KHz) (Typ.)	150	175	200	240	300	380	550	700	1000	
	Acceleration Sensitivity % FS/g Perpendicular	1.5x10 ⁻³	1.0x10 ⁻³	6.5x10 ⁻⁴	5.0x10 ⁻⁴	3.0x10 ⁻⁴	1.5x10 ⁻⁴	1.0x10 ⁻⁴	6.0x10 ⁻⁵	4.5x10 ⁻⁵	
	Insulation Resistance	100 Megohm Min. @ 50 VDC									
ENVIRONMENTAL	Operating Temperature Range	-65°F to +250°F (-55°C to +120°C)									
	Compensated Temperature Range	80°F to +180°F (25°C to +80°C) Any 100°F Range Within The Operating Range on Request									
	Thermal Zero Shift	± 1% FS/100°F (Typ.)									
	Thermal Sensitivity Shift	± 1% /100°F (Typ.)									
	Steady Acceleration	10,000g. (Max.)									
PHYSICAL	Linear Vibration	10-2,000 Hz Sine, 100g. (Max.)									
	Electrical Connection	4 Leads 36 AWG 36" Long									
	Weight	.3 Gram (Nom.) Excluding Module and Leads									
	Pressure Sensing Principle	Fully Active Four Arm Wheatstone Bridge Dielectrically Isolated Silicon on Silicon									

Note: Custom pressure ranges, accuracies and mechanical configurations available. Dimensions are in inches. Dimensions in parenthesis are in millimeters. All dimensions nominal. (K) Continuous development and refinement of our products may result in specification changes without notice. Copyright © 2014 Kulite Semiconductor Products, Inc. All Rights Reserved. Kulite miniature pressure transducers are intended for use in test and research and development programs and are not necessarily designed to be used in production applications. For products designed to be used in production programs, please consult the factory.